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APPLICATION NO.	F	ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/849,765	10/849,765 05/20/2004		Robert E. Ellefson	247_196	7362
20874	7590	06/23/2005		EXAMINER	
WALL MA		& BILINSKI	HASHMI, ZIA R		
SUITE 400	ISALINA	STREET		ART UNIT	PAPER NUMBER
SYRACUS	E, NY 13	3202		2881	

DATE MAILED: 06/23/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	
	10/849,765	ELLEFSON ET AL.	
Office Action Summary	Examiner	Art Unit	
	Zia R. Hashmi	2881	
The MAILING DATE of this communication Period for Reply	on appears on the cover sheet w	ith the correspondence address	
A SHORTENED STATUTORY PERIOD FOR F THE MAILING DATE OF THIS COMMUNICAT - Extensions of time may be available under the provisions of 37 (after SIX (6) MONTHS from the mailing date of this communicat - If the period for reply specified above is less than thirty (30) days - If NO period for reply is specified above, the maximum statutory - Failure to reply within the set or extended period for reply will, by Any reply received by the Office later than three months after the earned patent term adjustment. See 37 CFR 1.704(b).	TION. CFR 1.136(a). In no event, however, may a ion. s, a reply within the statutory minimum of thi period will apply and will expire SIX (6) MO y statute, cause the application to become A	reply be timely filed rty (30) days will be considered timely. NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).	
Status ·			
1)⊠ Responsive to communication(s) filed on 2a)□ This action is FINAL. 2b)⊠ 3)□ Since this application is in condition for a closed in accordance with the practice units.	This action is non-final. Illowance except for formal ma		
Disposition of Claims			
4) ⊠ Claim(s) 1-36 is/are pending in the application 4a) Of the above claim(s) is/are with 5) □ Claim(s) is/are allowed. 6) ⊠ Claim(s) 1-36 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction	ithdrawn from consideration.		
Application Papers			
9) The specification is objected to by the Ex 10) The drawing(s) filed on is/are: a) Applicant may not request that any objection Replacement drawing sheet(s) including the	accepted or b) objected to the drawing(s) be held in abeya correction is required if the drawin	ance. See 37 CFR 1.85(a). g(s) is objected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for for a) All b) Some * c) None of: 1. Certified copies of the priority docu 2. Certified copies of the priority docu 3. Copies of the certified copies of the application from the International E * See the attached detailed Office action for	uments have been received. uments have been received in e priority documents have bee Bureau (PCT Rule 17.2(a)).	Application No n received in this National Stage	
Attachment(s) 1) Notice of References Cited (PTO-892)		Summary (PTO-413)	
Notice of Draftsperson's Patent Drawing Review (PTO-9 Information Disclosure Statement(s) (PTO-1449 or PTO-1449 or PT	/	o(s)/Mail Date Informal Patent Application (PTO-152) 	

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1-36 are rejected under U.S.C. 103(a) as being unpatentable over Patterson et al. (6,064,156), in view of Keller et al. (4,123,686).
- 3. With respect to independent claims 1, 15, 22 and 31, Patterson et al. disclose an ion source for a mass analysis system, the ion source comprising: means for forming an electron stream (Abstract, lines 1-3 & 16-19 and col. 1, lines 7-10); an anode having an interior region into which said formed electron stream is injected, said electron stream terminating within the anode region and in which ions are formed (col. 1, lines 7-10, col. 6, lines 26-30 & 47-60, and 100 in Fig. 4). Patterson et al. further disclose a method for improving the contamination of the ion source, said ion source including an anode structure defining an interior region, said interior anode region receiving an electron stream wherein ions are formed in said region (Abstract, lines 4-10, col. 1, lines 11-15, and col. 3, lines 21-30). They also mention of ion sources using thermionic emitters generally consisting of a wire at elevated temperature (col. 1, lines 18-25).
- 4. With respect to claims 1-36, Patterson et al. fail to disclose a releasable or removable anode liner or shield for an ion source. Keller et al., however, disclose an ion

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generating source with replaceable anode shield, the ion source comprising means for producing primary electrons which cause production of highly charged ions (col. 1, lines 26-27, 30-40, & 49-56, col. 2, lines 41-46, col. 3, lines 52-55, and 4 in Fig. 1-5). Keller et al. further disclose an ion extraction means for extracting ions from the anode region (col. 3, lines 28-33 & 60-62, and 28 in Fig. 3).

It would have been obvious to one having ordinary skill at the time of the invention was made to combine the methods and apparatus of Patterson and Keller et al., because Keller et al. teach (col. 1, lines 36-45) that in order to produce highly charged ions of any desired element for use in physical or industrial research, a constant radiation source of ions of specific charge needs to be maintained over a period of time.

Conclusion

- 5. Kagadei et al. disclose (6,765,216) a method and apparatus for producing atomic flows of molecular gases by a magnetron discharge using heated cathode.
- 6. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Zia Hashmi whose telephone number is (571) 272-2473. The examiner can normally be reached between 8.30 AM- 5 PM. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John R. Lee can be reached on (571) 272-2477.

Zia Hashmi

June 20, 2005

JOHN R. LEE

SUPERVISORY PATENT EXAMINER